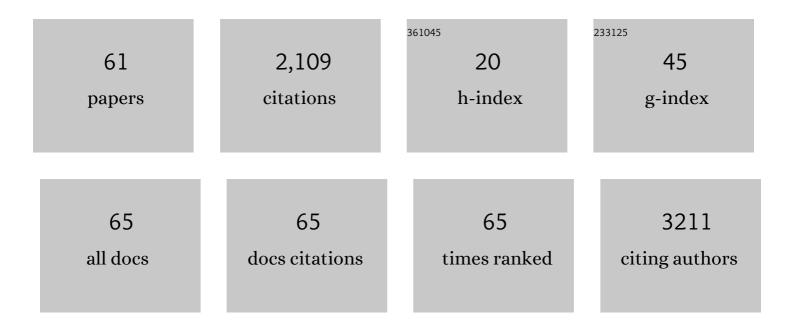
## Munho Kim

List of Publications by Year in descending order

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Μυνήο Κιμ

| #  | Article   | IF  | CITATIONS |
|----|---|-----|-----------|
| 1  | High-performance green flexible electronics based on biodegradable cellulose nanofibril paper.<br>Nature Communications, 2015, 6, 7170.   | 5.8 | 707       |
| 2  | Recent advances in free-standing single crystalline wide band-gap semiconductors and their<br>applications: GaN, SiC, ZnO, β-Ga <sub>2</sub> O <sub>3</sub> , and diamond. Journal of Materials<br>Chemistry C, 2017, 5, 8338-8354. | 2.7 | 180       |
| 3  | Origami silicon optoelectronics for hemispherical electronic eye systems. Nature Communications, 2017, 8, 1782.   | 5.8 | 177       |
| 4  | Flexible Phototransistors Based on Singleâ€Crystalline Silicon Nanomembranes. Advanced Optical<br>Materials, 2016, 4, 120-125.  | 3.6 | 76        |
| 5  | Single-crystalline germanium nanomembrane photodetectors on foreign nanocavities. Science<br>Advances, 2017, 3, e1602783.   | 4.7 | 76        |
| 6  | 226 nm AlGaN/AlN UV LEDs using p-type Si for hole injection and UV reflection. Applied Physics Letters, 2018, 113, .  | 1.5 | 59        |
| 7  | High Aspect Ratio β-Ga <sub>2</sub> O <sub>3</sub> Fin Arrays with Low-Interface Charge Density by<br>Inverse Metal-Assisted Chemical Etching. ACS Nano, 2019, 13, 8784-8792.   | 7.3 | 57        |
| 8  | 229 nm UV LEDs on aluminum nitride single crystal substrates using p-type silicon for increased hole<br>injection. Applied Physics Letters, 2018, 112, .  | 1.5 | 52        |
| 9  | Enhanced Performance of Ge Photodiodes <i>via</i> Monolithic Antireflection Texturing and α-Ge<br>Self-Passivation by Inverse Metal-Assisted Chemical Etching. ACS Nano, 2018, 12, 6748-6755.                                       | 7.3 | 50        |
| 10 | High Performance Flexible Visible-Blind Ultraviolet Photodetectors with Two-Dimensional Electron<br>Gas Based on Unconventional Release Strategy. ACS Nano, 2021, 15, 8386-8396.  | 7.3 | 38        |
| 11 | High-performance flexible BiCMOS electronics based on single-crystal Si nanomembrane. Npj Flexible<br>Electronics, 2017, 1, .   | 5.1 | 36        |
| 12 | Nanoscale groove textured β-Ga2O3 by room temperature inverse metal-assisted chemical etching and photodiodes with enhanced responsivity. Applied Physics Letters, 2018, 113, .   | 1.5 | 36        |
| 13 | Flexible crystalline β-Ga <sub>2</sub> O <sub>3</sub> solar-blind photodetectors. Journal of Materials<br>Chemistry C, 2020, 8, 14732-14739.  | 2.7 | 34        |
| 14 | Low dimensional freestanding semiconductors for flexible optoelectronics: materials, synthesis, process, and applications. Materials Research Letters, 2020, 8, 123-144.  | 4.1 | 32        |
| 15 | Flexible germanium nanomembrane metal-semiconductor-metal photodiodes. Applied Physics Letters,<br>2016, 109, .   | 1.5 | 30        |
| 16 | Transferrable single crystalline 4H-SiC nanomembranes. Journal of Materials Chemistry C, 2017, 5,<br>264-268.   | 2.7 | 30        |
| 17 | CMOS-Compatible Catalyst for MacEtch: Titanium Nitride-Assisted Chemical Etching in Vapor phase for<br>High Aspect Ratio Silicon Nanostructures. ACS Applied Materials & Interfaces, 2019, 11, 27371-27377.                         | 4.0 | 28        |
| 18 | Self-Anchored Catalyst Interface Enables Ordered Via Array Formation from Submicrometer to<br>Millimeter Scale for Polycrystalline and Single-Crystalline Silicon. ACS Applied Materials &<br>Interfaces, 2018, 10, 9116-9122.      | 4.0 | 26        |

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| #  | Article  | IF   | CITATIONS |
|----|--|------|-----------|
| 19 | Metal-Semiconductor-Metal GeSn Photodetectors on Silicon for Short-Wave Infrared Applications.<br>Micromachines, 2020, 11, 795.  | 1.4  | 24        |
| 20 | Producing Silicon Carbide Micro and Nanostructures by Plasmaâ€Free Metalâ€Assisted Chemical Etching.<br>Advanced Functional Materials, 2021, 31, 2103298.  | 7.8  | 22        |
| 21 | Light absorption enhancement in Ge nanomembrane and its optoelectronic application. Optics Express, 2016, 24, 16894.   | 1.7  | 21        |
| 22 | Modulation of light absorption in flexible GeSn metal–semiconductor–metal photodetectors by<br>mechanical bending. Journal of Materials Chemistry C, 2020, 8, 13557-13562.                                       | 2.7  | 21        |
| 23 | Polycrystalline GeSn thin films on Si formed by alloy evaporation. Applied Physics Express, 2015, 8, 061301.   | 1.1  | 20        |
| 24 | Enzymeâ€Programmable Microgel Lasers for Information Encoding and Antiâ€Counterfeiting. Advanced<br>Materials, 2022, 34, e2107809.   | 11.1 | 20        |
| 25 | Ultra-thin distributed Bragg reflectors via stacked single-crystal silicon nanomembranes. Applied<br>Physics Letters, 2015, 106, .   | 1.5  | 16        |
| 26 | P-type silicon as hole supplier for nitride-based UVC LEDs. New Journal of Physics, 2019, 21, 023011.  | 1.2  | 16        |
| 27 | Lasing action in microdroplets modulated by interfacial molecular forces. Advanced Photonics, 2021, 3, .   | 6.2  | 15        |
| 28 | Direct Chemisorption-Assisted Nanotransfer Printing with Wafer-Scale Uniformity and Controllability. ACS Nano, 2022, 16, 378-385.  | 7.3  | 15        |
| 29 | Tunable biaxial in-plane compressive strain in a Si nanomembrane transferred on a polyimide film.<br>Applied Physics Letters, 2015, 106, .   | 1.5  | 14        |
| 30 | Flexible Titanium Nitride/Germanium-Tin Photodetectors Based on Sub-Bandgap Absorption. ACS<br>Applied Materials & Interfaces, 2021, 13, 61396-61403.  | 4.0  | 14        |
| 31 | Distinct UV–Visible Responsivity Enhancement of GaAs Photodetectors via Monolithic Integration of<br>Antireflective Nanopillar Structure and UV Absorbing IGZO Layer. Advanced Optical Materials, 2022,<br>10, . | 3.6  | 13        |
| 32 | Resonant cavity germanium photodetector via stacked single-crystalline nanomembranes. Journal of<br>Vacuum Science and Technology B:Nanotechnology and Microelectronics, 2016, 34, .                             | 0.6  | 12        |
| 33 | Fabrication of Ge-on-insulator wafers by Smart-Cut <sup>TM</sup> with thermal management for undamaged donor Ge wafers. Semiconductor Science and Technology, 2018, 33, 015017.                                  | 1.0  | 11        |
| 34 | Amorphous Si/SiO2 distributed Bragg reflectors with transfer printed single-crystalline Si<br>nanomembranes. Journal of Vacuum Science and Technology B:Nanotechnology and Microelectronics,<br>2016, 34, .      | 0.6  | 10        |
| 35 | A highly ordered and damage-free Ge inverted pyramid array structure for broadband antireflection in the mid-infrared. Journal of Materials Chemistry C, 2021, 9, 9884-9891.                                     | 2.7  | 10        |
| 36 | Strain-free GeSn nanomembranes enabled by transfer-printing techniques for advanced optoelectronic applications. Nanotechnology, 2020, 31, 445301.   | 1.3  | 10        |

| #  | Article  | IF  | CITATIONS |
|----|--|-----|-----------|
| 37 | Anti-reflective porous Ge by open-circuit and lithography-free metal-assisted chemical etching. Applied<br>Surface Science, 2021, 546, 149083. | 3.1 | 9         |

## Raman scattering study of GeSn under ã€<sup>1</sup> 0 0〉 and ã€<sup>1</sup> 1 0〉 uniaxial stress. Nanotechnology, 2021, 32, **B5**5704. 9

| 39 | An Intrinsically Microâ€∤Nanostructured Pollen Substrate with Tunable Optical Properties for<br>Optoelectronic Applications. Advanced Materials, 2021, 33, e2100566.          | 11.1 | 9 |
|----|---|------|---|
| 40 | Black Germanium Photodetector Exceeds External Quantum Efficiency of 160%. Advanced Materials<br>Technologies, 2022, 7, 2100912.  | 3.0  | 8 |
| 41 | Tunable Optical Vortex from a Nanogroove-Structured Optofluidic Microlaser. Nano Letters, 2022, 22, 1425-1432.  | 4.5  | 8 |
| 42 | Releasable AlGaN/GaN 2D Electron Gas Heterostructure Membranes for Flexible Wideâ€Bandgap<br>Electronics. Advanced Electronic Materials, 2022, 8, 2100652.                    | 2.6  | 8 |
| 43 | Switched transmission-line type Q-band 4-bit MMIC phase shifter using InGaAs pin diodes. Electronics<br>Letters, 2010, 46, 219.   | 0.5  | 7 |
| 44 | High-Sensitivity and Mechanically Compliant Flexible Ge Photodetectors with a Vertical p–i–n<br>Configuration. ACS Applied Electronic Materials, 2021, 3, 1780-1786.          | 2.0  | 7 |
| 45 | Triaxial compressive strain in bilayer graphene enabled by nitride stressor layer. Extreme Mechanics<br>Letters, 2017, 11, 77-83.   | 2.0  | 6 |
| 46 | Producing Microscale Ge Textures via Titanium Nitride―and Nickelâ€Assisted Chemical Etching with<br>CMOSâ€Compatibility. Advanced Materials Interfaces, 2021, 8, 2100937.     | 1.9  | 5 |
| 47 | Effect of thickness on the electronic structure and optical properties of quasi two-dimensional perovskite CsPbBr3 nanoplatelets. Journal of Luminescence, 2021, 239, 118392. | 1.5  | 5 |
| 48 | An InGaAs PIN-diode based broadband traveling-wave switch with high-isolation characteristics. , 2009, , .  |      | 4 |
| 49 | Ultraviolet antireflective porous nanoscale periodic hole array of 4H-SiC by Photon-Enhanced<br>Metal-assisted chemical etching. Applied Surface Science, 2022, 581, 152387.  | 3.1  | 4 |
| 50 | A heavily doped germanium pyramid array for tunable optical antireflection in the broadband mid-infrared range. Journal of Materials Chemistry C, 2022, 10, 5797-5804.        | 2.7  | 3 |
| 51 | Direct Imaging of Weakâ€ŧo trong oupling Dynamics in Biological Plasmon–Exciton Systems. Laser and Photonics Reviews, 2022, 16, .   | 4.4  | 3 |
| 52 | Germainum photodetectors coupled with silicon waveguides on a flexible substrate using nanomembrane transfer printing method. , 2013, , .                                     |      | 1 |
| 53 | High performance flexible phototransistors based on transferrable silicon nanomembranes. , 2016, , .  |      | 1 |
| 54 | Fabrication and Characterization of Si/GaInP Heterojunction Photodetectors. , 2012, , .   |      | 0 |

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|----|--|----|-----------|
| 55 | Cavity enhanced 1.5î¼ m LED with silicon as a hole injector. , 2016, , .   |    | Ο         |
| 56 | Nano-indented Ge surfaces by metal-assisted chemical etching (MacEtch) and its application for optoelectronic devices. , 2017, , . |    | 0         |
| 57 | Design and Analysis of Tensile-Strained GeSn Mid-Infrared Photodetectors on Silicon. , 2019, , .                                   |    | 0         |
| 58 | Design and Analysis of Tensile-Strained GeSn Mid-Infrared Photodetectors on Silicon. , 2019, , .                                   |    | 0         |
| 59 | Flexible single-crystalline GeSn metal-semiconductor-metal photodetectors. , 2021, , .   |    | Ο         |
| 60 | Photodetecting MOSFET based on ultrathin single-crystal germanium nanomembrane. , 2016, , .  |    | 0         |
| 61 | Germanium photodiodes on pyramidal textured surface by Metal-Assisted Chemical Etching. , 2019, , .                                |    | 0         |